

IN THE SPECIFICATION:

Please replace the paragraph beginning at page 1, line 1, with the following rewritten paragraph:

--The present application cites the basic applications of Japanese Patent Application NO. 2000-54181 (filed on February 29, 2000), Japanese Patent Application No. 2000-40501 (filed on February 16, 2001) claiming priority of the application No. 2000-54181, and Japanese Patent Application No. 2000-91904 (filed on March 29, 2000), and enjoys the benefits of the applications. This application is a divisional of U.S. application Serial No. 09/794,864, filed February 27, 2001.--

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U.S. PATENT.
No. 6,623,423.*
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Please replace the paragraph beginning at page 16, line 23, with the following rewritten paragraph:

-- When the holding sensing device 30 is held and the electrostatic capacitance is large, the potential at the sensing device 30 is lower than the potential at the capacitor C1. The output of the comparator is therefore driven high. The capacitance of the capacitor C1 or the resistances of the resistors R1 and R2 are determined to meet the above conditions.--

Please replace the paragraph beginning at page 23, line 9, with the following rewritten paragraph:

-- To be more specific, the scissors-like handpiece 3A' is different from the scissors-like handpiece 3A described in relation to the first embodiment in a point that the LED 41A is disposed near the treatment member 16A projecting from the tip of the sheath 14a 14A. Moreover, a hook-like handpiece 3B' shown in Fig. 9 has an LED 41B disposed near the treatment member 16B thereof.--